

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of :  
Satoshi TAKANO : **Mail Stop: PCT**  
Serial No. NEW : Attorney Docket No. 2006\_1415A  
Filed August 24, 2006 :

SUBSTRATE PROCESSING APPARATUS  
[Corresponding to PCT/JP2005/009107  
Filed May 12, 2005]

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**CLAIM OF PRIORITY**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicant in the above-entitled application hereby claims the date of priority under the International Convention of Japanese Patent Application No. 2004-146113, filed May 17, 2004. The priority document was received by International Bureau on June 16, 2005. A copy of PCT/IB/304 is submitted herewith.

Respectfully submitted,

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ATTACHMENT "H"